

Search Notes

Application/Control No.

10/708,297

Examiner

Richard H. Kim

Applicant(s)/Patent under
Reexamination

CHEN, PO-LUN

Art Unit

2871

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East text search (349/\$)- jpo,epo,uspat, pgpub-see printout	2/16/2006	RHK